

Appl. No.11/910,217  
Amdt. Dated October 29, 2010  
Reply to Final Office Action of July 30, 2010

Attorney Docket No. 374611-000087  
Customer No. 73230

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Koichiro NIIRA, et al.

Serial No.: 11/910,217

Confirmation No.: 3698

Filed: September 28, 2007

For: POLYCRYSTALLINE SILICON  
SUBSTRATE, METHOD FOR  
PRODUCING SAME,  
POLYCRYSTALLINE SILICON  
INGOT, PHOTOELECTRIC  
CONVERTER AND PHOTOELECTRIC  
CONVERSION MODULE

Art Unit: 1793

Examiner: Jun Li

**AMENDMENT UNDER 37 C.F.R. § 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated July 30, 2010, please amend the above-referenced application as follows:

**Amendments** to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.